

Notice of References Cited	Application/Control No. 10/054,621	Applicant(s)/Patent Under Reexamination KRUGER ET AL.	
	Examiner Paul D Kim	Art Unit 3729	Page 1 of 1

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	B	US-6,377,423	04-2002	Dill et al.	360/126
	C	US-6,226,149	05-2001	Dill et al.	360/126
	D	US-5,491,600	02-1996	Chen et al.	360/322
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.